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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q85096

Masamichi INENAGA, et al.

Appln. No.: 10/516,693

Group Art Unit: 2877

Confirmation No.: 6877

Examiner: Isiaka O. Akanbi

Filed: December 6, 2004

For: WAFER PRE-ALIGNMENT APPARATUS AND METHOD

RESPONSE UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 28, 2006, please consider the remarks as submitted herewith on the accompanying pages.